



Attorney Docket No.:SAM-0422
Application Serial No.: 10/600,724
Reply to Office Action of: August 20, 2004

J.F.W.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Sang-don Yi Examiner: Mai, Anh D.
Serial No.: 10/600,724 Group Art Unit: 2814
Filing Date: June 20, 2003
Title: SILICON-ON-INSULATOR WAFER AND METHOD OF MANUFACTURING
THE SAME

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

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11-18-04

Date

Walter, Maria

Vanessa Marakas

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT A

Sir:

The following is in response to the Office Action dated August 20, 2004, and is filed within the shortened statutory period of three months. Please amend the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.